## AMENDMENTS TO THE TITLE AND THE SPECIFICATION

Please cancel the title of record and substitute the following new title therefor:

## -- POLISHING SLURRY FOR TEXTURING--

Paragraph starting at line 8 of page 1 has been amended as follows:

This invention relates to polishing slurry for and a method of texturing the surface of a magnetic hard disk substrate.

Paragraph starting at line 18 of page 5 has been amended as follows:

It is therefore an object of this invention in view of the problems of prior art technologies to provide new polishing slurry for and a method of forming very fine texturing marks on the surface of a magnetic hard disk substrate at a density greater than 80 marks/ $\mu$ m in the direction of the radius without abnormal protrusions.

Paragraph starting at line 5 of page 18 has been amended as follows:

Polishing slurry for texturing the surface of a magnetic hard disk substrate has abrading particles with diameters in the range of 1-10nm dispersed in a dispersant such as water and a water-based aqueous solution. The abrading particles may be monocrystalline diamond particles, polycrystalline diamond particles or cluster particles with monocrystalline and polycrystalline diamond particles. A method of texturing a surface of a magnetic hard disk substrate includes the steps of rotating the magnetic hard disk substrate, supplying polishing slurry of this invention on the surface of the substrate, and pressing a polishing tape on the substrate surface and running the polishing tape.